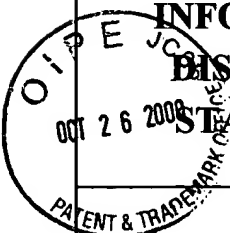


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|  <b>INFORMATION<br/>DISCLOSURE<br/>STATEMENT</b> | <b>Atty. Docket No.:</b> 150.00650102          | <b>Serial No.:</b> 09/603,132 |
|  |  |                               |
|  | <b>Applicant(s):</b> Brian A. Vaartstra et al. |                               |
|  | <b>Filing Date:</b> June 23, 2000              | <b>Group:</b> 2825            |

**U.S. PATENT DOCUMENTS**

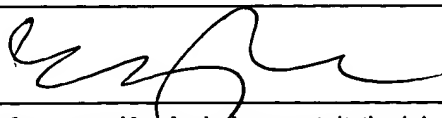
| Examiner Initial | Document Number | Date     | Name              | Class | SubClass | Filing Date If Appropriate |
|------------------|-----------------|----------|-------------------|-------|----------|----------------------------|
| EL               | 4,907,052       | 03/06/90 | Takada et al.     |       |          |                            |
| EL               | 5,168,332       | 12/92    | Kunishima et al.  |       |          |                            |
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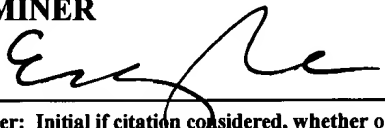
|    | Document Number | Date     | Country | Class | SubClass | Translation |    |
|----|-----------------|----------|---------|-------|----------|-------------|----|
|    |                 |          |         |       |          | Yes         | No |
| EL | 0 856 879       | 08/05/98 | EPO     |       |          |             |    |
|    |                 |          |         |       |          |             |    |
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| <b>EXAMINER</b>    | <b>Date Considered</b> 3/27/01 |
| *Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. |                                |

|  |   |                        |
|--|---|------------------------|
| <b>INFORMATION<br/>DISCLOSURE<br/>STATEMENT</b><br> | Atty. Docket No.: 150.00650102          | Serial No.: 09/603,132 |
|  |   |                        |
|  | Applicant(s): Brian A. Vaartstra et al. |                        |
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| EXAMINER<br>   |  | Date Considered<br>3/27/01   |
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